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| 2292 7590 05/30/2008 BIRCH STEWART KOLASCH & BIRCH PO BOX 747 EALLS CHURCH, VA 22040 0747 | | | EXAMINER | |
| | | | LEE, SHUN K | |
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Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

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| | Application No. | Applicant(s) | | |
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| | 09/806,457 | CASPERSEN, CHRISTIAN | | |
| Office Action Summary | Examiner | Art Unit | | |
| | Shun Lee | 2884 | | |
| The MAILING DATE of this communication ap Period for Reply | ppears on the cover sheet with the | correspondence address | | |
| A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING DESIGNATION OF THE MAILING | DATE OF THIS COMMUNICATIO .136(a). In no event, however, may a reply be tind d will apply and will expire SIX (6) MONTHS from te, cause the application to become ABANDONE | N. mely filed the mailing date of this communication. ED (35 U.S.C. § 133). | | |
| Status | | | | |
| Responsive to communication(s) filed on <u>07 /</u> This action is FINAL . 2b) ☐ This action is FINAL . Since this application is in condition for allowated closed in accordance with the practice under | is action is non-final. ance except for formal matters, pr | | | |
| Disposition of Claims | | | | |
| 4) | awn from consideration. 7,44 and 47-51 is/are rejected. | ne application. | | |
| Application Papers | | | | |
| 9) The specification is objected to by the Examin 10) The drawing(s) filed on <u>06 April 2001</u> is/are: a Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the E | a) accepted or b) objected to e drawing(s) be held in abeyance. Se ction is required if the drawing(s) is ob | e 37 CFR 1.85(a). ejected to. See 37 CFR 1.121(d). | | |
| Priority under 35 U.S.C. § 119 | | | | |
| 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. | | | | |
| Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date | 4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal I 6) Other: | ate | | |

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DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 7 April 2008 has been entered.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1, 7, 9, 11, 12, 23, 24, 27, 29, 36, 37, and 47-49 are rejected under 35 U.S.C. 103(a) as being unpatentable over Malin *et al.* (US 5,377,002) in view of Hamashima *et al.* (US 4,744,663).

The claim limitation "scanning means for scanning the specimen in relation to the detector" is being treated under 35 U.S.C. 112, sixth paragraph and has been construed to cover the corresponding structure described in the specification (*e.g.*, "The scanning means may comprise a DC motor and a spindle rigidly connected to the DC motor" in lines 32-33 on pg. 4 and "The scanning means may also comprise deflecting means that may comprise a servo motor or a stepper motor connected to the member holding the specimen and thereby adapted to scan the first light beam

along a radius of the circular movement of the disc holding the specimen" in lines 2-5 on pg. 5) and equivalents thereof (MPEP § 2181).

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The claim limitation "means for rotating the member" is being treated under 35 U.S.C. 112, sixth paragraph and has been construed to cover the corresponding structure described in the specification (*e.g.*, "The scanning means may comprise a DC motor and a spindle rigidly connected to the DC motor" in lines 32-33 on pg. 4) and equivalents thereof (MPEP § 2181).

The claim limitation "means for displacing the member along a radius of the rotation of the member" is being treated under 35 U.S.C. 112, sixth paragraph and has been construed to cover the corresponding structure described in the specification (*e.g.*, "The scanning means may also comprise deflecting means that may comprise a servo motor or a stepper motor connected to the member holding the specimen and thereby adapted to scan the first light beam along a radius of the circular movement of the disc holding the specimen" in lines 2-5 on pg. 5) and equivalents thereof (MPEP § 2181).

The claim limitation "scanning control means for controlling the scanning means for scanning the specimen" is being treated under 35 U.S.C. 112, sixth paragraph and has been construed to cover the corresponding structure described in the specification (*e.g.*, "The scanning control means may comprise servo means adapted control the rpm of the disc, to produce a substantially constant linear velocity of the laser spot on the disc surface, a principle well known from CD players" in lines 27-29 on pg. 16) and equivalents thereof (MPEP § 2181).

The claim limitation "storage means for storing detector signals relating to the marked objects provided by the detector and corresponding position signals provided by the scanning control means" is

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being treated under 35 U.S.C. 112, sixth paragraph and has been construed to cover the corresponding structure described in the specification (*e.g.*, "The storage means may comprise magnetic, optic or electric storage media, such as hard disc drives, DAT-tapes, floppy discs, CD-ROM discs, EEPROMs, etc. which may be utilised for non-volatile storage of the coherent data sets obtained from the scanning of the specimen(s). The storage means may also comprise intermediate volatile storage means, preferably RAM, to store coherent data sets during the scanning" in lines 9-14 on pg. 14) and equivalents thereof (MPEP § 2181).

The claim limitation "means for retrieving the position signals stored in the storage means" is being treated under 35 U.S.C. 112, sixth paragraph and has been construed to cover the corresponding structure described in the specification (*e.g.*, "The storage means may be located in a personal computer (PC), which is operationally connected with the apparatus of the present invention" in lines 8-9 on pg. 14) and equivalents thereof (MPEP § 2181).

It should be noted that a claim containing a "recitation with respect to the manner in which a claimed apparatus is intended to be employed does not differentiate the claimed apparatus from a prior art apparatus" (*Ex parte Masham*, 2 USPQ2d 1647 (Bd. Pat. App. & Inter. 1987)) if the prior art apparatus teaches all the structural limitations of the claim (MPEP § 2114). Thus, "wherein the marked objects are marked with a fluorescent stain" was not given any patentable weight since the object marked by a fluorescent stain is not a component of the claimed apparatus and does not appear to impose any additional structural limitations on the claimed apparatus.

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In regard to claim **1**, Malin *et al.* disclose (Fig. 1) an apparatus for identifying a position of objects having unknown positions and detecting a property of the objects contained in a specimen (11), the apparatus comprising:

- (a) a frame (28.1);
- (b) a member (13) positioned on the frame (28.1) and having a surface that is adapted to receive and hold the specimen (11);
- (c) at least a first light source (2) for emitting at least a first light beam (1) towards the specimen (11) held by the member (13), wherein the first light beam (1) is adapted to provide a light spot (12) having a diameter on the specimen (11);
- (d) at least one beam-splitter (18 or 62 in Figs. 1 and 4a) being arranged to reflect the first light beam (1) towards the specimen (11);
- (e) at least a detector (19) for detecting light (14, 15) emitted from the objects upon interaction with the first light beam (1), the first light source (2) and the detector (19) being arranged so that a part of a light beam path from the first light source
 (2) to the specimen (11) is co-axial (along optical axis 34) with a part of the light (14, 15) emitted from the objects;
- (f) scanning means (27.1, 27, 27.2, 28.2, 28) for scanning the entire surface of the member (13) in relation to the detector (19) along a non-linear curve (*e.g.*, " ... the whole of the surface is scanned along a spiral path ... "; column 10, lines 26-29), wherein the scanning means (27.1, 27, 27.2, 28.2, 28) comprises means (shaft 27.1 of a rotary motor 27) for rotating the member (13) and means (linear stage 27.2 on a spindle 28.2 of translation motor 28) for displacing the member (13) along a radius

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of the rotation of the member (13), so as to identify the position of the objects in the entire specimen (11) and detect the property of the objects, the means (27.1, 27) for rotating and the means (27.2, 28.2, 28) for displacing being directly connected to the member (13), the member (13) being rotatable and displaceable along a radius of the rotation of the member (13):

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- (g) scanning control means (computer unit 22, interface 26, rotation-pulse emitter 29, translation-pulse emitter 30) for controlling the scanning means (27.1, 27, 27.2, 28.2, 28) for scanning the specimen along the non-linear curve (column 10, lines 26-29);
- (h) storage means (computer unit 22, mass-storage system 23) for storing detector signals (column 9, lines 35-40) relating to the objects provided by the detector (19) and corresponding position signals (column 9, lines 41-45) provided by the scanning control means (22, 26, 29, 30);
- (i) means (computer unit 22) for retrieving the position signals stored in the storage means (22, 23), and
- (j) a microscope (*e.g.*, " ... scanning laser-beam microscope ... "; column 5, lines 17-23) for viewing images of the objects, wherein the scanning control means uses the retrieved position signals to place the microscope at the position of the objects to allow performing a detailed examination of the objects (column 12, lines 61-68).

The apparatus of Malin *et al.* lacks to filter through the beam-splitter fluorescent light emitted from the specimen, thereby allowing fluorescent light from fluorescently marked objects to pass through the beam-splitter to the detector and an explicit description that

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the light spot diameter is between 20-150 µm. However, Malin et al. also disclose (column 12, lines 48-54) that the " ... unit of measurement used for LPDs is the µmLSE (=micron latex-sphere equivalent), where 1 µmLSE is the diffused-light amplitude produced by a latex sphere of 1 µm diameter ... ", (column 8, lines 30-33) that " ... LPDs are relatively small in relation to the light spot ... ", and (column 2, lines 57-62) that "In scanning, the astigmatic light beam produced by the switchable lens system covers a larger area and thus permits a larger feed offset from one revolution to the next. On the other hand, the dot-shaped light beam is used with a small feed offset and makes possible high local resolution". That is, a light spot diameter of >1 μ m (e.g., 50 μ m) is taught or suggested by Malin et al. since the diameter of the light spot is larger than LPDs having diameters in units of micrometers (e.g., 1 µm). Further, Hamashima et al. teach (column 4, lines 47-59) to provide a dichroic mirror (24 in Fig. 1) for simultaneously detecting three kinds of light information (i.e., the scattered light from the edge of the pattern, the reflection from the pattern and the fluorescence or phosphorescence from the pattern) so that by using these three kinds of light information and the scanning position information of the beam spot, the desired edge detection, pattern position detection and line width and dimension measurement of the different patterns (e.g., the photoresist pattern and the polysilicon pattern) are performed in a diversified manner. Therefore, it would have been obvious to one having ordinary skill in the art at the time of the invention to provide a dichroic mirror as the at least one beam-splitter and other optical components in the apparatus of Malin et al., in order to obtain reflection, scattering, and fluorescence measurements at a desired resolution (e.g., from a 50 µm light spot diameter) so as to determine defects and contamination in a diversified manner.

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In regard to claim **7** which is dependent on claim 1, Malin *et al.* also disclose (Fig. 1) that the member (13) is positioned for rotation about an axis on the frame (28.1) and wherein the means (27.1, 27) for rotating the member (13) rotates the member (13) about the axis.

In regard to claim **9** which is dependent on claim 1, Malin *et al.* also disclose (Fig. 1) that the scanning control means (22, 26, 29, 30) are adapted to control the scanning means (27.1, 27, 27.2, 28.2, 28) in such a way that the non-linear curve is a substantially circular curve (*e.g.*, " ... the whole of the surface is scanned along a spiral path ... "; column 10, lines 26-29).

The claim limitation "means for sampling and digitising the detector signals and the position signals" is being treated under 35 U.S.C. 112, sixth paragraph and has been construed to cover the corresponding structure described in the specification (*e.g.*, "Each of these digitised detector and position signals is, preferably, represented by a series of digital samples generated by one or several A/D-converters" in lines 13-15 on pg. 9) and equivalents thereof (MPEP § 2181).

In regard to claim **11** which is dependent on claim 1, Malin *et al.* also disclose (Figs. 1 and 5a) means (analog-digital converter 78, rotation-pulse emitter 29, translation-pulse emitter 30) for sampling and digitizing the detector signals and the position signals.

The claim limitation "signal processing means operatively connected to the detector to detect a presence of an object based on the detector signals" is being treated under 35 U.S.C. 112, sixth paragraph and has been construed to cover the corresponding structure described in

the specification (*e.g.*, "Signal processing means may subsequently retrieve and use these corresponding coherent data sets to enhance the discrimination between signals originating from target objects and false positive signals" in lines 7-9 on pg. 11 and "The storage means may be located in a personal computer (PC), which is operationally connected with the apparatus of the present invention" in lines 8-9 on pg. 14) and equivalents thereof (MPEP § 2181).

In regard to claim **12** which is dependent on claim 1, Malin *et al.* also disclose (Fig. 1) signal processing means (analyzer electronics 21, computer unit 22) operatively connected to the detector (19) to detect a presence of an object based on the detector signals.

In regard to claim **23** which is dependent on claim 1, Malin *et al.* also disclose (Fig. 1) that a mask (16) is inserted in the optical path between the specimen (11) and the detector (19), wherein the mask (16) comprises at least one transparent aperture (*e.g.*, a slit; column 7, lines 25-29).

In regard to claim **24** which is dependent on claim 23, Malin *et al.* also disclose (Fig. 1) that aperture is a substantially rectangular shape (*e.g.*, a slit; column 7, lines 25-29).

In regard to claim **27** which is dependent on claim 1, Malin *et al.* also disclose (Fig. 1) that the first light source (2) is a coherent light source (*e.g.*, 488 nm laser; column 4, lines 8-12).

In regard to claim **48** which is dependent on claim 1, Malin *et al.* also disclose that the position signals of the marked objects are angular and radial coordinates (*i.e.*, "... polar coordinates ..."; column 10, lines 11-13).

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In regard to claims 29, 36, 47, and 49, the cited prior art is applied as in claims 1 and 48 above.

In regard to claim 37 which is dependent on claim 36, the cited prior art is applied as in claim 11 above.

4. Claims 15, 16, 50, and 51 are rejected under 35 U.S.C. 103(a) as being unpatentable over Malin *et al.* (US 5,377,002) in view of Hamashima *et al.* (US 4,744,663) as applied to claims 1 and 29 above, and further in view of Worster *et al.* (US 5,479,252).

In regard to claims **15** and **16** (which are dependent on claim 1) and claims **50** and **51** (which are dependent on claim 29), the modified apparatus and method of Malin *et al.* lacks an explicit description that the specimen has an area larger than 500 mm² (*e.g.*, larger than 8000 mm²). However, Malin *et al.* also disclose (column 1, lines 18-22) that the specimen is, *e.g.*, a substrate for optical applications or a wafer. Since Malin *et al.* do not disclose and/or require a specific specimen, one having ordinary skill in the art at the time of the invention would reasonably interpret the unspecified specimen of Malin *et al.* as any one of the known conventional specimens that did not require a detailed description. Further, Worster *et al.* teach (column 4, lines 58-60) that wafer diameters range from 75 mm to 200 mm. Therefore it would have been obvious to one having ordinary skill in the art at the time of the invention to provide a known conventional specimen (*e.g.*, 200 mm diameter wafer) as the unspecified specimen in the modified apparatus and method of Malin *et al.*

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5. Claim 44 is rejected under 35 U.S.C. 103(a) as being unpatentable over Malin *et al.* (US 5,377,002) in view of Hamashima *et al.* (US 4,744,663) as applied to claim 1 above, and further in view of Raz *et al.* (US 6,049,421).

In regard to claim **44** which is dependent on claim 1, the modified apparatus of Malin *et al.* lacks an explicit description that the detector comprises a CCD device. Since Malin *et al.* do not disclose and/or require a specific detector, one having ordinary skill in the art at the time of the invention would reasonably interpret the unspecified detector of Malin *et al.* as any one of the known conventional detectors that did not require a detailed description. Further, Raz *et al.* teach (column 2, lines 26-37) to provide a CCD device for scanning a substrate in order to obtain reasonable speed resolution. Therefore it would have been obvious to one having ordinary skill in the art at the time of the invention to provide a known conventional detector (*e.g.*, a CCD) as the unspecified detector in the modified apparatus of Malin *et al.*

Response to Arguments

6. Applicant's arguments filed 7 April 2008 have been fully considered but they are not persuasive.

Applicant argues ("Claim Rejections Under 35 U.S.C. § 103" section of remarks filed 7 April 2008) that none of the cited prior art individually or in combination teach or suggest the limitations of amended independent claims 1 and 29 or their dependent claims since the fluorescent light from the sample is reflected by the beam splitter (52 in Fig. 1 of Hamashima *et al.*) wherein the fluorescent light is simply filtered by the filter (58 in Fig. 1) and not by the beam splitter (52 in Fig. 1). Examiner respectfully

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disagrees. First it is noted that the 5 February 2008 Office Action states (pg. 7) that " ... Hamashima et al. teach (column 4, lines 47-59) to provide a dichroic mirror (24 in Fig. 1) ... ". Thus it is unclear why applicant's arguments are not directed to the dichroic mirror 24 cited in the prior Office Action. Further in response to applicant's argument, the test for obviousness is not whether the features of a secondary reference may be bodily incorporated into the structure of the primary reference; nor is it that the claimed invention must be expressly suggested in any one or all of the references. Rather, the test is what the combined teachings of the references would have suggested to those of ordinary skill in the art. See In re Keller, 642 F.2d 413, 208 USPQ 871 (CCPA 1981). In this case, Hamashima et al. state (column 3, line 27 to column 4, line 31) that a " ... laser light source 10, forming an excitation light source for the production of fluorescence, ... laser beam ... is reflected by a dichroic mirror 24 to fall on an objective lens 26. The dichroic mirror 24 has such a spectrum characteristic that the laser beam is reflected and other light of longer wavelengths is transmitted. ... pattern is excited by the short-wave laser beam to emit fluorescence or phosphorescence. The fluorescence is generally a visible light having a wavelength of 500 to 700 nm and it is longer in wavelength than the laser beam. As a result, after passing through the objective lens 26, the fluorescence from the pattern is passed through the dichroic mirror 24 ... and then it is directed to a photodetector 60 comprising a photomultiplier or the like through a filter 58 which cuts off the light rays in the wavelength range of the laser beam ...". Thus Hamashima et al. expressly teach a dichroic mirror (24 in Fig. 1) that reflects excitation light (from light source 10 to the sample W) and passes fluorescence emitted by the sample (to a photodetector 60). Therefore, the combined teachings of the cited prior art

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would have suggested the limitations of amended independent claims 1 and 29 or their dependent claims to those of ordinary skill in the art.

Conclusion

7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Shun Lee whose telephone number is (571) 272-2439. The examiner can normally be reached on Monday-Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Porta can be reached on (571) 272-2444. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Constantine Hannaher/
Primary Examiner, Art Unit 2884